Record of Letter Ballot Review by TC Chapter for Procedural Review

Region/Locale: North America

Global Technical Committee: MEMS/NEMS

TC Chapter Cochairs: Steve Martell/Sonoscan, Win Baylies/Bay-Tech Resor

Standards Staff: Laura Nguyen

	Scheduled in Background Statement	Actual
Date	07/13/2017	07/13/2017
Location	San Francisco, CA	San Francisco, CA
Reason for Change of Date and/or Location (if changed)		

Note: See Regulations ¶ 9.5 Exception for allowable reason to change.

I. Document Number and Title

Document Number	Document Title
6176	Reapproval of SEMI MS1-0307 (Reapproved 0812),
	Guide to Specifying Wafer-Wafer Bonding Alignment
	Target

II. Tally

Standards staff to fill in.

Voting Tally: As-cast tally after close of voting period

Note: A minimum of 60% of the Voting Interests that have TC Members within the global technical committee that issued the Letter Ballot must return Votes. (*Regulations* ¶ 9.7.1.1)

Voting Tally (with example values):

Returned Votes		Distribution		Return Rate	
20	÷	33	=	60.6%	≥60%
27]				
0		Total	Vote	rs with Rejects	0
20					
	20 27 0	20 ÷ 27 0	20 ÷ 33 27 0 Total	20 ÷ 33 = 27 0 Total Vote	20 ÷ 33 = 60.6% 27 0 Total Voters with Rejects

Note: See Regulations § 3.2.1 for definition of Voting Interest.

III. Rejects

None

IV. Other Technical Issues

None

V. Comments

None

VI. Editorial Changes Other than Those Voted on in § V

VII. Approval Conditions Check

VII. - (i). Approval Rate

APPROVAL CONDITION 1: All Negatives have been discussed and were withdrawn, found not related, found not persuasive, or addressed by a technical change. (*Regulations* ¶ 9.7.1.2)

APPROVAL CONDITION 2: At least 90% of the sum of valid Voting Interest Accept and Voting Interest Reject Votes must be Accept. (*Regulations* ¶ 9.7.1.3)

Note: If both approval conditions are not satisfied, the Document fails.

		Accepts		(Accepts + Valid Rejects)			
Approval Rate	=	20	1	20	=	100.0%	≥90%

VII. – (ii) Approval Level (check one)

Note: See Regulations § 9.7.2 for further information.

X	Globally Approved (No Ratification Ballot needed): The Letter Ballot meets the Letter Ballot approval conditions for the global technical committee.
	Need a Ratification Ballot: The Letter Ballot meets the Letter Ballot approval conditions for the TC Chapte and a Ratification Ballot will be issued to validate technical changes.

VIII. Safety Check

Note: See Regulations § 15 for further information.

	X	T is	This is not a Safety Document , when all safety-related information is removed, the Document is still technically sound and complete. (<i>Regulations</i> ¶ 8.7.1)						
Motion			This is a Safety Document , when all safety-related information is removed, the Document is not technically sound and complete. (<i>Regulations</i> ¶ 8.7.2)						
	Safety Checklist (<i>Regulations</i> ¶ 15.3) is complete and has been included with the Doctor throughout the balloting process. (<i>Regulations</i> ¶ 15.1.2)								
	Motion by/2 nd by			Richard Allen (NIST) / Bevan Wu (BW & Associates/ITRI)					
	Discussion			None					
		\ \	ote	4 Y 0 N; Motion passed.					

IX. Intellectual Property (IP) Check

Note: This Letter Ballot may cover all or part of a Standard or Safety Guideline. This IP check applies to the entire Standard or Safety Guideline. See *Regulations* § 16 for further information.

X	The TC Chapter meeting chair asked those participating, if they were aware of any potentially material patented technology or copyrighted items* in the Standard or Guideline. (<i>Regulations</i> ¶ 8.8.1)			
	x	No potentially material patented technology or reproduction of copyrighted items is known.	GO TO SECTION X.	

^{*} Note: Such potentially material patented technology or copyrighted items might have become known since the Standard or Safety Guideline was last reviewed, or might become relevant due to this Letter Ballot.

X. Action for This Document

Motion	X	This Docu	This Document passed TC Chapter review as balloted and will be forwarded to the ISC A&R SC for procedural review.				
I	Motion by		Richard Allen (NIST) / Chris Moore (Frontier Semiconductor)				
[Discussion		None				
Vote		ote	4 Y 0 N				
-	Final Act		Final Action		X Motion passed		
	iiiai	ACCION	Motion failed				

Standards staff to record the result of the A&R procedural review here:

		Approved for publication
A&R		Approved pending acceptance of the Ratification Ballot
Αακ		Not approved
	Re	Reason: